



DATA SHEET



- IE Replaced by Windows Application
- Test Plan Generator
- Built-in Curve Tracer/I-V Sweeps
- MSSQL Database
- GPIB Prober Drivers
- System Maint. (Calibration, Self Test)
- DR YIELD SW for Plots, Maps, Reports

Overview

Reedholm's test executive software is designed for automated semiconductor parametric testing. It provides a complete solution, along with an easy to use UI. All test routines are built in, so code development is not necessary, but is available. Everything is stored (test plans, conditions, results) in a single database hosted on a current, networked, fully supported version of SQL server.

This data driven software environment makes programming optional. Many find the use of standardized test types leads to better data and faster test times, resulting in more actionable data with as much as 3.9x more throughput compared to other legacy systems.

The file based formats of the 1980's eventually became the RDS Intranet versions of the new century. The offering was expanded to include an SQL database and simplification of the editing process from the original "Q&A" test plan creation process to one of filling in cells for a given test type

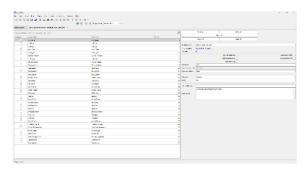


Figure 1 - Database Export Scheme

RDS 2.0 Deliverables

This release continues the evolution of the data driven software environments, while providing a thoroughly modern approach to parametric testing that can be fully supported by today's IT departments and device/test engineers.

WIN 2.0 / RDS 2.0 Parametric Test Software

The Internet Explorer (IE) interface from RDS Intranet is eliminated and the obsolete elements have been replaced. It is a natural upgrade path for customers of the legacy Reedholm systems, as well as a starting point for new customers that want to leverage off a platform proven to be suitable for high volume test operations.

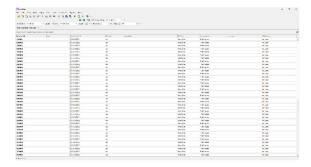


Figure 2 – Overview Intradie Test Lists

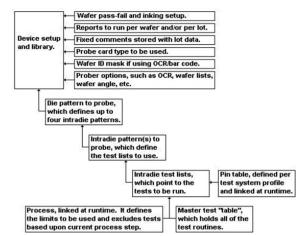
Customers running either the classic RDS-DOS software versions (8.1 or later) and/or RDS Intranet software should be able to update to RDS 2.0, Deliverables include:

- Reedholm SW version 2.0
- DR YIELD SW for graphical display of trend charts, wafer maps, I-V plots and the like.
- Engineering services (Migration, training).

Test Plan Hierarchy

The test plan elements required to do automatic testing involve more than just test lists and probing patterns. These elements include processes, devices, pin tables, reports, pass-fail criteria, and prober control options. The following diagram illustrates the test plan hierarchy:

Figure 3 – Automated Testing







Test Plan Creation

WIN 2.0 / RDS 2.0 contains a comprehensive set of test routines that cover bipolar, depletion FET, and enhancement FET technologies implemented on Si, GaAs, GaN, and SiC materials. Years of experience supporting customers resulted in a robust, fast, and flexible test engine with these features:

- Prober driver and probe site editor.
- Lot reports and test data exporting.
- Version control of test library and plans.
- Test routine code documentation.
- Test conditions (pins, voltages, etc.).
- System manuals and training guides. With RDS 2.0, one can program every routine from scratch, or leverage off the library of field proven test routines that have tested millions upon millions of devices:

2 Terminal Resistance - Force Current or Voltage 3 Terminal Voltage or Resistance 4 Terminal Voltage, Resistance, or van der Pauw Beta at an lb. lc or le Calculate Delta Length Current at a Voltage Early Effect gm or Vt at an lds or % of lds gm or Vt at 2 lds, 2Vgs, or PMS High Voltage (+2kV) Continuous & Snapback BV Ic - Sweep Vce, Step Ib Ic – Sweep Vce, Step Vbe
Ic and Ib – Sweep Vbe
Ids – Sweep Vds, Step Vgs and Vbs lds - Sweep Vgs, Step Vbs lds - Sweep Vgs, Step Vds lds at a Vgs Isub - Sweep Vgs, Step Vds Measure Capacitance at 0V, ±100V, or +2kV Measure Capacitance – Sweep ±100V or +2kV Measure Current or Voltage Measure Current - Sweep Time Measure Current - Sweep Voltage Measure Current at High Voltage (+2kV) Measure Resistance – Low Bias Measure Resistance – Sweep Voltage Measure Resistance at Current Measure Resistance (4T) - Sweep Current Measure Resistance at Voltage Measure Voltage – Low Bias Measure Voltage – Sweep Time Measure Voltage (4T) - Sweep Current Replace Test Parameters with Prior Results Saturated Vt Small Signal Beta Standalone Equations & SQL Extractions Step Voltage Until Current Stress at a Vgs Stress Current User Written Test Vgs at an lds, % of lds, or Peak Isub Voltage at a Current (±100V or +200V)

Figure 4 – Subset of available Test Types

Dozens of fields in a database record are populated when setting up a test. That record is downloaded to a test controller and executed in real time without any delays for compiling. Setting up and controlling test

plans is similar to populating spreadsheet files. The test engine supports:

- Multiple pins per DUT leg (drain, gate, etc.).
- Biasing and grounding extra DUT pins.
- Forcing voltage or current on extra pins.
- · Executing user input equations.
- Using prior test results for test conditions.



Figure 5 - Test Configuration Screen

After a test is created and found effective, being in record format makes it easy to copy and use as the starting point in setting up a new test.

Setting Up Test Plans with BUILD

The **test list** edit screen lists the tests set up to be run in production. New and existing tests can be inserted, cut, copied, etc. Tests to be skipped upon test passing or failing can also be set.



Figure 6 – Edit Intradie Test List

Tests can be executed within Build to look for interaction issues between tests/structures. If the checkbox next to test is filled, that test will be executed during automatic probing. This allows for including characterization tests in a test list that could come in handy when troubleshooting.





Setting up Die Patterns

The graphical die pattern editor is used to quickly create probe patterns, including the 10 site pattern one shown in figure 7.

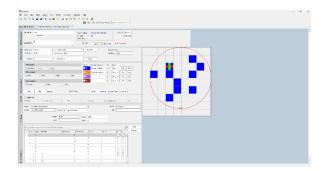


Figure 7 - Die Pattern Editor

Other die pattern editor features include:

- Up to four different Intradie test patterns can be run.
- Separate die move and prober alignment sizes
- Single die X & Y offset step for misplaced PCMs.
- Separate target and first die locations.
- Tool to select all die and remove outliers.
 Sub-moves are called Intra-Die moves in the application and are shown below:



Figure 8 – Intradie Pattern Editor

Quality Data AND Fast Test Times

RDS 2.0 allows the system to take data like a curve tracer inclusive of the prober analog cable. Thus, it is no longer necessary to take a wafer to another station to generate characteristic curves and then try to match results between systems. This capability can eliminate uncertainty about device behavior and what test conditions to use to assure the highest quality data. A curve, or set of curves, can be created for nearly every test type.

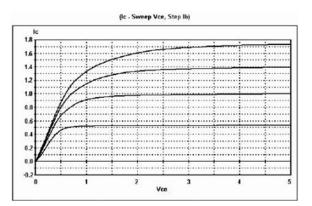


Figure 9 – IV Data

Prober Control

GPIB or IEEE-488 drivers exist for most commercial probers, and new ones can be developed. Some of the selections used for setting up the prober are shown below:

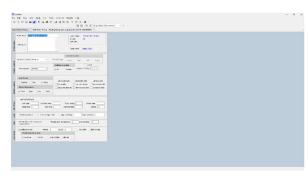
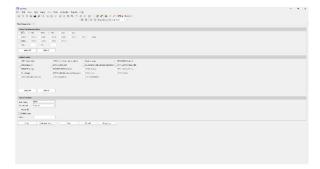


Figure 10 – Prober Setup

Maintenance Tools

Software tools ensure that the software, computer hardware, and instruments are running within specification, to calibrate the modules if necessary, and to troubleshoot and identify failing modules.

Figure 11 – Diag. Setup







SQL Database

The Reedholm database is named RIWEBSQL. Tables in this database serve many purposes. The UI tables hold the text labels, screen information, text messages, and data-binding properties for all of the screens and menus. There are temporary tables (whose names begin with "tmp_ and zimp_") that serve as a kind of 'scratch paper' for stored procedures, including storing raw data for imports and exports.

The test plans and device designs are organized in still other tables, which support multiple versions and locking of records to keep production processes secure. There are also the various test data tables, where lot data, plot data, and reliability data are saved for future extraction and analysis. Finally, numerous tables exist to manage the database and were created and are maintained by MS SQL Server software. Most of these tables start with "sys".

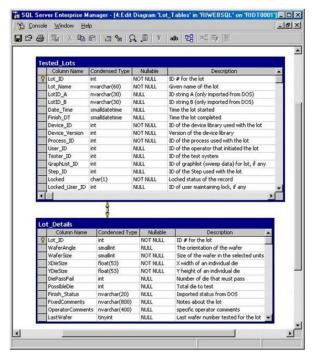


Figure 12 – UI Table

Validating Everything Works

Before a lot can be started, the data entered and their associated elements such as probing patterns, test lists, etc., must all be validated - which occurs when the Validate button is clicked. The validation involves hundreds of checks to ensure proper operation/validation including:

- Making sure all tests have limit tables for the selected process.
- That the probing patterns and test lists are correct.
- That the elements that make up a device (probe setup, pass-fail setup, reports, etc.) are all working correctly.

- That none of the items to be used are currently being edited.
- That the device must be released.
- That the probe/DUT card touchdown count has not exceeded the maximum.

Once all the test parameters have been validated, the test sequence for the lot can be started. Starting a lot also results in the application controls and menus being disabled, preventing errant interruptions from halting lot testing. Once the lot has finished testing and unloading the last wafer if applicable, controls and menus are enabled again.

Reports

Reports are generated through third party DR YIELD applications which pull data directly from the stored test results that can also be accessed from the database. Reports include:

- Raw data using engineering notation w/4digits.
- Lot summary for all wafers, engineering notation w/4 digits and showing target value.
- · Wafer pass-fail summary by test.
- Wafer pass-fail summary by die with # die to pass.
- Wafer pass-fail summary by die with % die to fail set at 45 %.
- Wafer process time summary.
- Execution time summary of each test in lot.
- Limits, target, units, and order of tests run in lot.

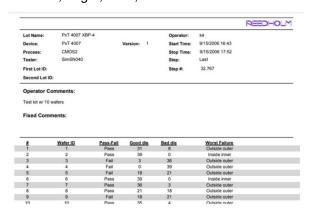


Figure 13 – Wafer Die Test Results